

In re Application of:

Pan et al.

Serial No.: 08/682,935

Filed: July 16, 1996

For: TECHNIQUE FOR ELIMINATION OF PITTING ON SILICON SUBSTRATE

DURING GATE STACK ETCH

Examiner: H. Nguyen

Group Art Unit: 2812

Attorney Docket No.: 2915US(96-0149)

NOTICE OF EXPRESS MAILING

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PRELIMINARY AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Prior to examination of the claims on the merits in the above-identified application, please amend this application as follows:

IN THE CLAIMS:

Please cancel claims 1-22.

REMARKS

No new subject matter has been introduced with these amendments.

Entry of the above preliminary amendment is respectfully requested. This amendment is submitted prior to the issuance of the first Office action. No new matter has been added.

Respectfully submitted,

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RGW/cw

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